

Docket No.: 50090-338



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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	RESPONSE UNDER 37 CFR 1.116
	:	<u>EXPEDITED PROCEDURE</u>
	:	
Hiroyuki AMISHIRO, et al.	:	Customer Number: 20277
	:	Confirmation Number: 5812
	:	
Application No.: 09/960,495	:	Group Art Unit: 2813
	:	Examiner: D. Hogans
	:	
Filed: September 24, 2001	:	
	:	
For: SEMICONDUCTOR DEVICE WITH RESISTOR ELEMENTS FORMED ON INSULATING FILM	:	

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Remarks are submitted in response to the Office Action dated May 21, 2004, pursuant to the provisions of 37 C.F.R. § 1.116.

REMARKS

At the time of the Office Action dated May 21, 2004, claims 1-21 were pending in this application. Of those claims, claims 1-3, 5, 9, 11 and 13 have been rejected and claims 14-20 have been withdrawn from consideration pursuant to the provisions of 37 C.F.R. § 1.142(b). Applicants acknowledge, with appreciation, the Examiner's indication on page 14 of the Office Action that claims 4, 6-8, 10, 12 and 21 contain allowable subject matter.